

PATENT
5957-07300

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Inventor: | Patrick Schiavone, et al. | § | Atty.Dkt.No.: | 5957-07300 |
| Serial Number: | 09/462,716 | § | Examiner: | Alexander G. Ghyka |
| Filing Date: | August 6, 2001 | § | Group/Art Unit: | 2812 |
| Title: | METHOD FOR MINIMIZING THE CORNER EFFECT BY DENSIFYING THE INSULATING LAYER | § | Conf. No.: | 5431 |
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LETTER TO EXAMINER

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

I would like to bring to your attention the following reference, which was cited in the International Search Report and provided to the Patent Office, but which does not appear to have been officially considered:

Gaillard, F, et al., Silicon Dioxide Chemical Vapor Deposition Using Silane and Hydrogen Peroxide, 7/1/96, pp. 2767-2769.

Respectfully submitted,

Date: July 5, 2007

By: /Dean M. Munyon/
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